

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant: **TSAI, John C.**For (title): **SYSTEM FOR ROTATION MEASUREMENT WITH LASER
INTERFEROMETRY**5 Filing Date: **20/08/2004** Examiner: **LYONS, MICHAEL A.**
Serial No: **10/711,090** Art Unit: **2877**10 Mail Stop Non-Fee Amendment
Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 2231315 **RESPONSE TO OFFICE ACTION AND AMENDMENT**

Sir:

20 In response to the Office Action dated 08/04/2006, Applicant submits the following
remarks and amendment, currently due on a statutory period for response now extending through
11/04/2006.